

Adaptive Optics Development for LIGO

L S C

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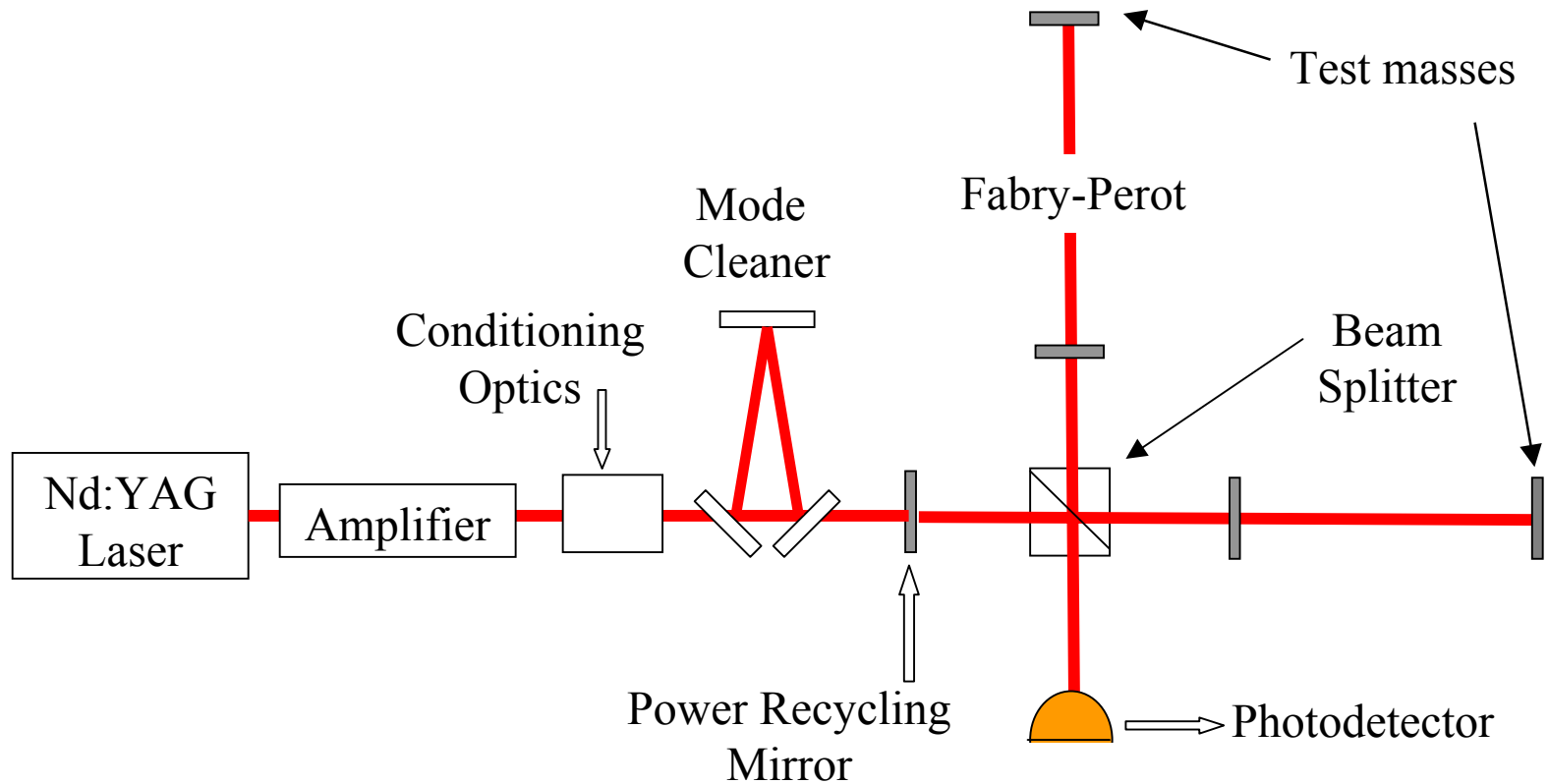


Outline

- Motivation
- Deformable Mirror (DM) Design
- Experimental results
- Future Work
- Conclusions



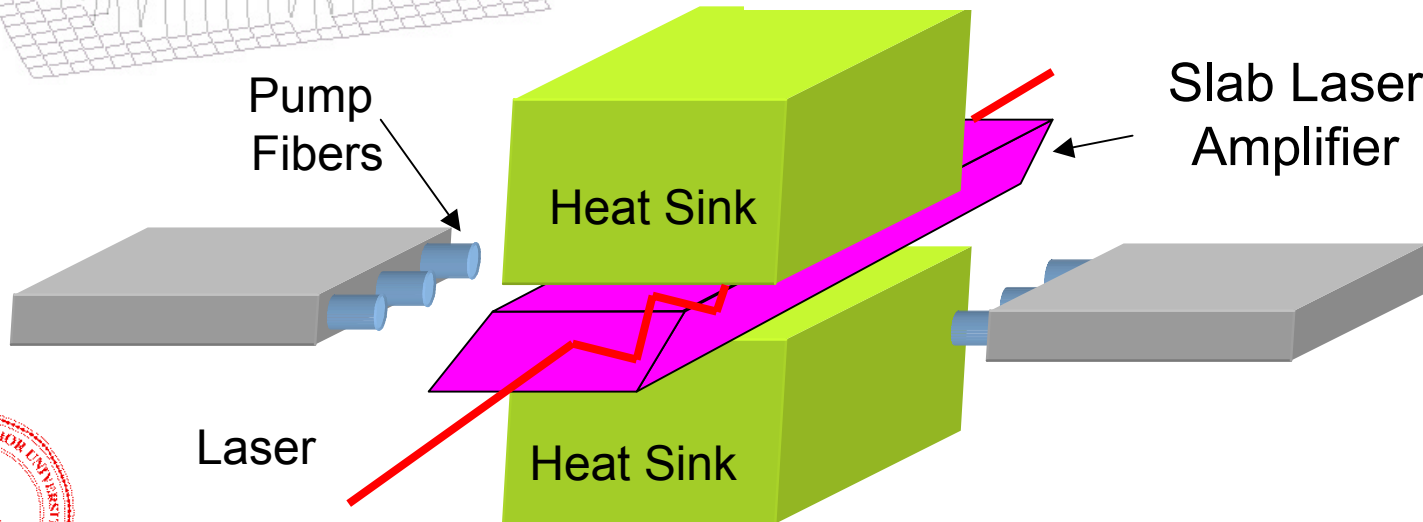
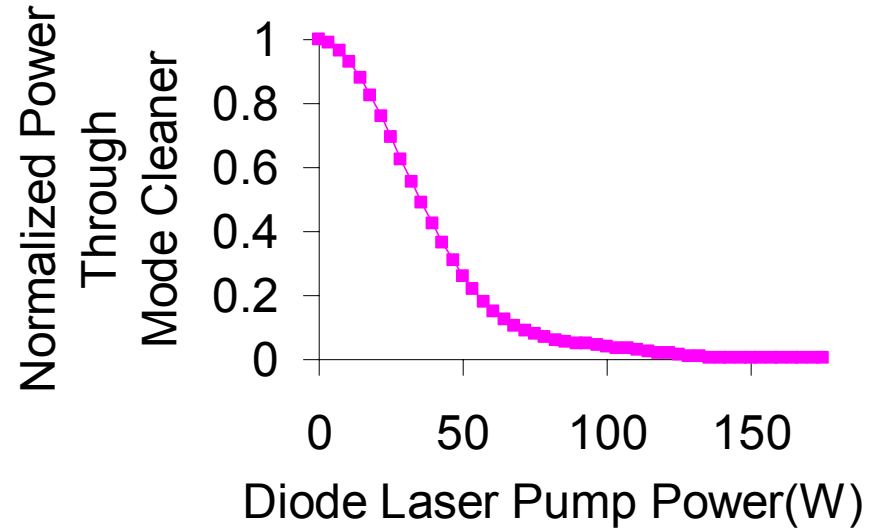
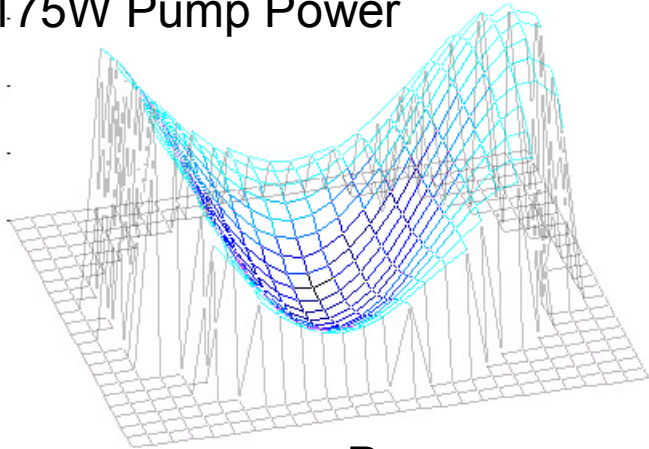
Laser Interferometer Gravitational-Wave Observatory



Slab Thermal Distortions

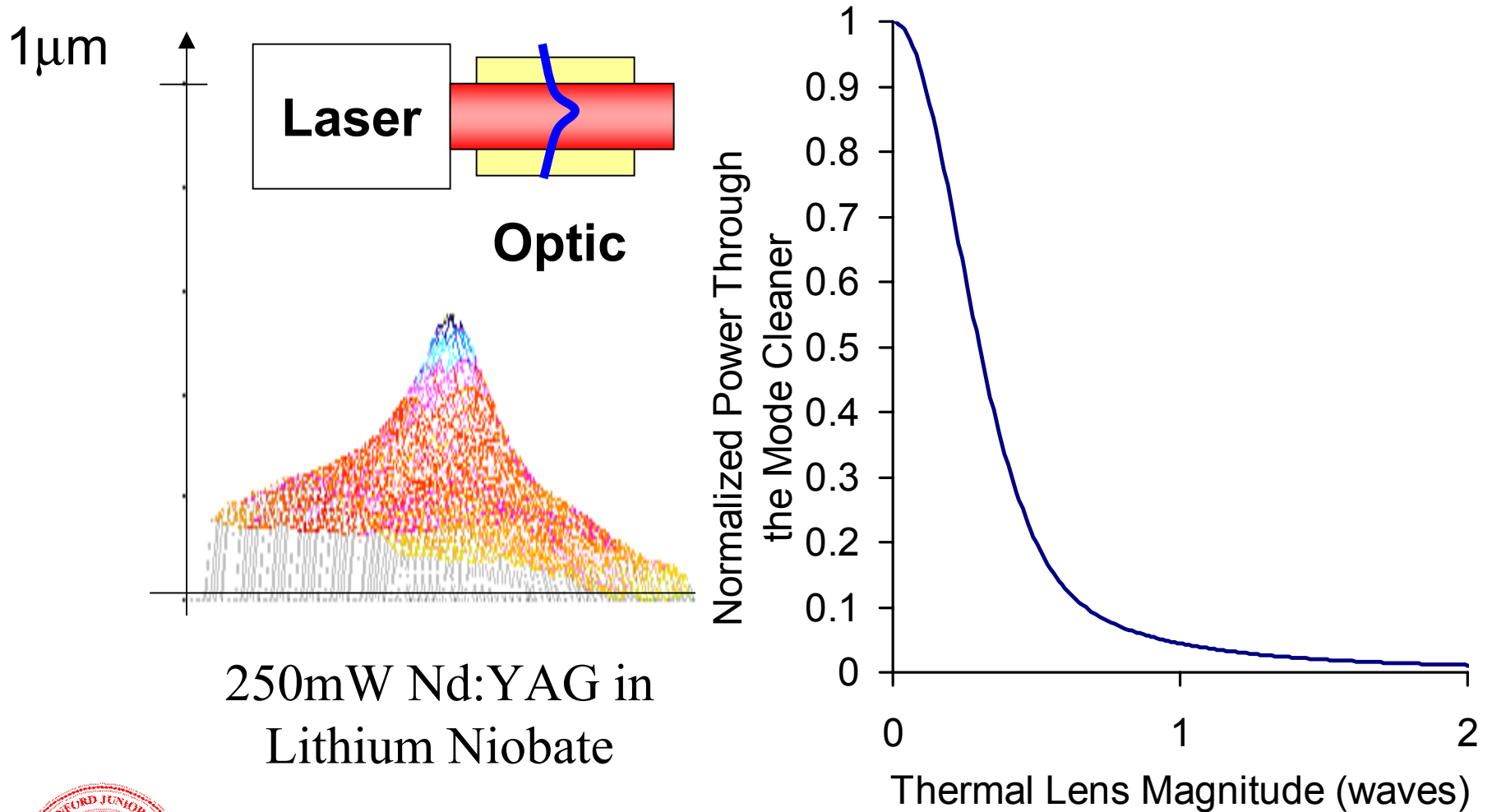
Tilt-Removed Wavefront

Peak-to-Valley: 813nm
1.75W Pump Power



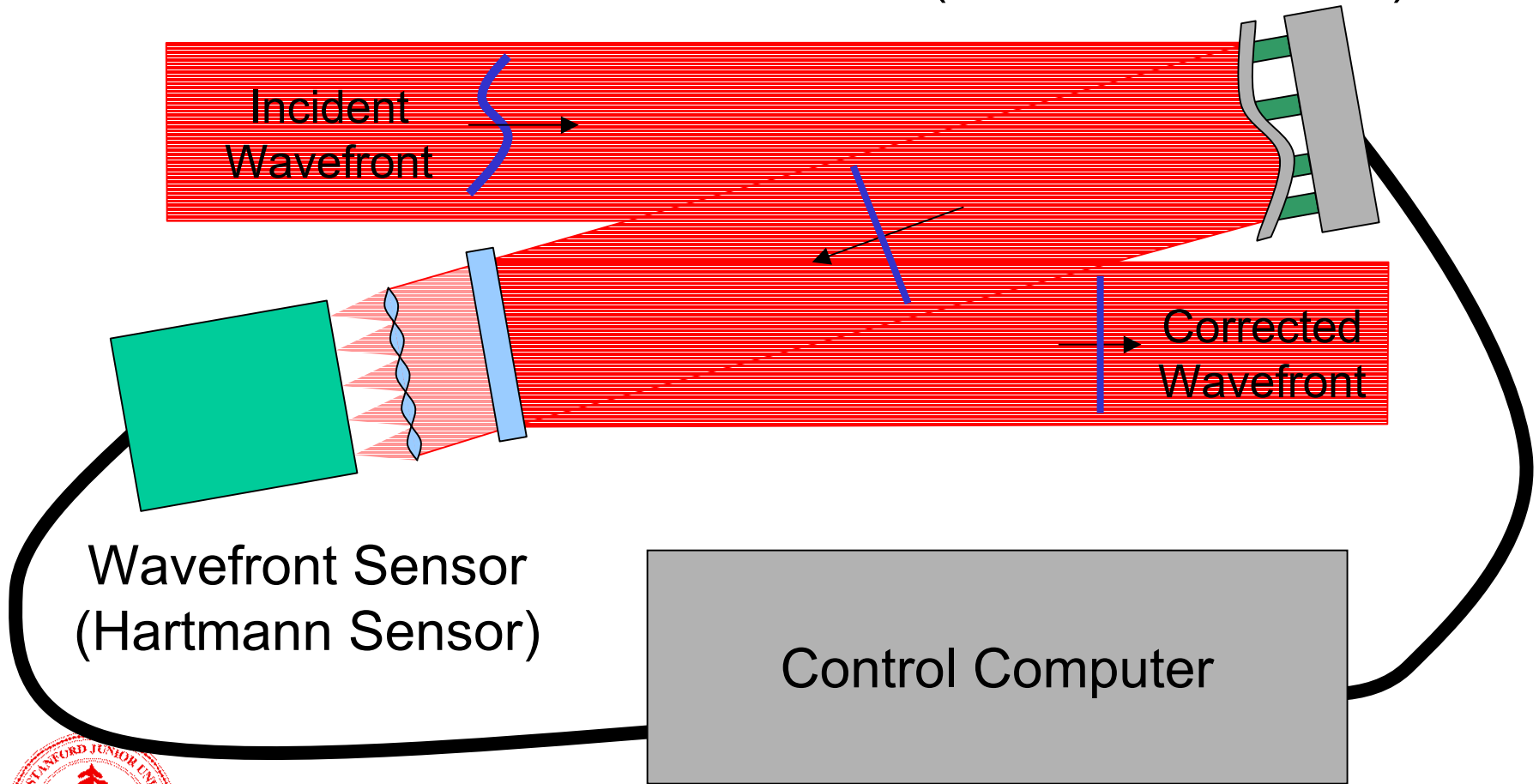
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Transmissive Optic Thermal Lens



Basic Adaptive Optics (AO) System

Spatial Phase Modulator
(Deformable Mirror)

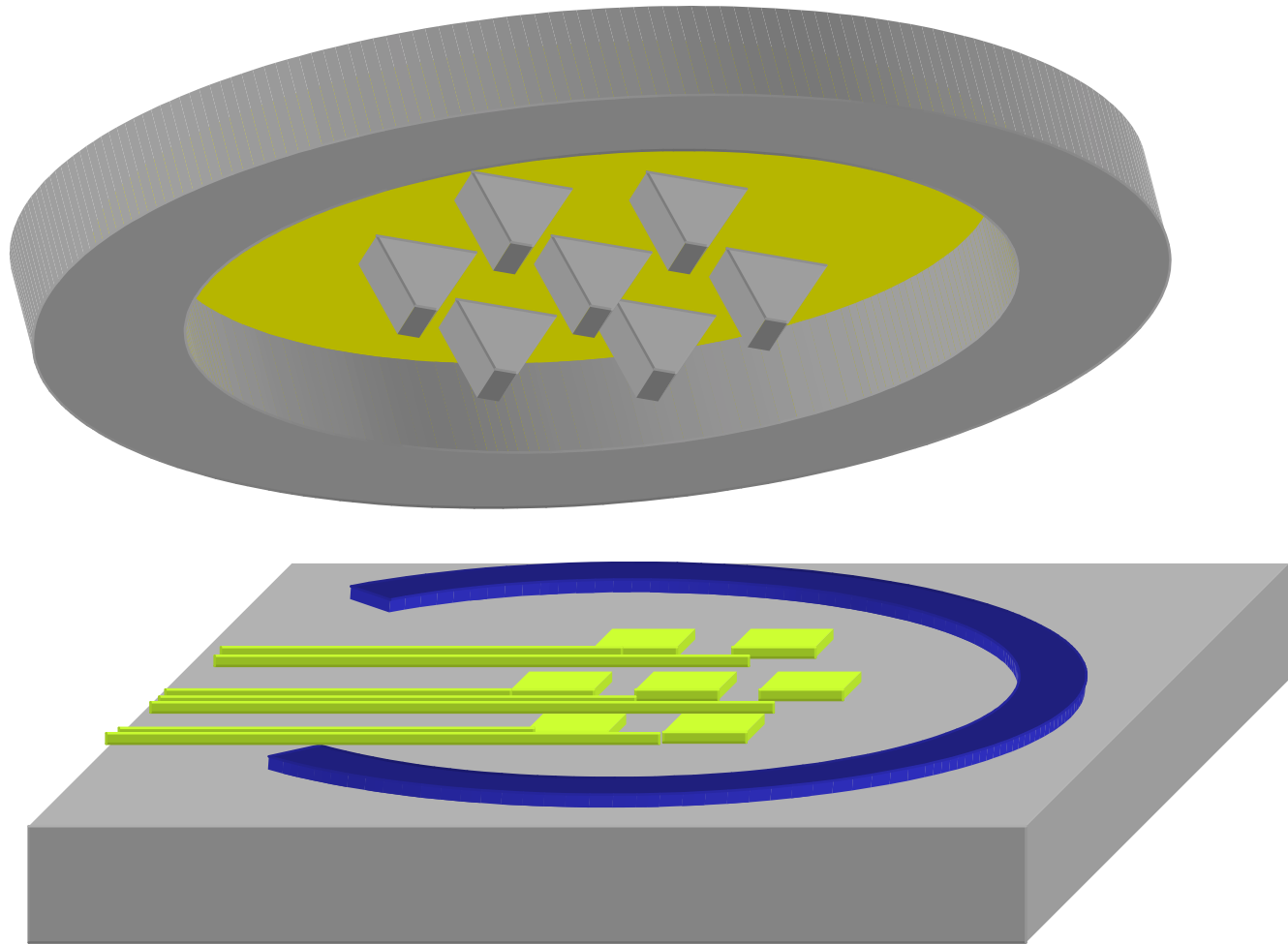


What architecture for high power?

- Liquid crystal spatial phase modulators
 - Absorbing ITO damages easily
- Segmented mirrors
 - Diffractive effects, edges damage
- Surface micromachined mirrors
 - Surface perforations are damage sites
- Bulk micromachined mirrors
 - Most have high crosstalk

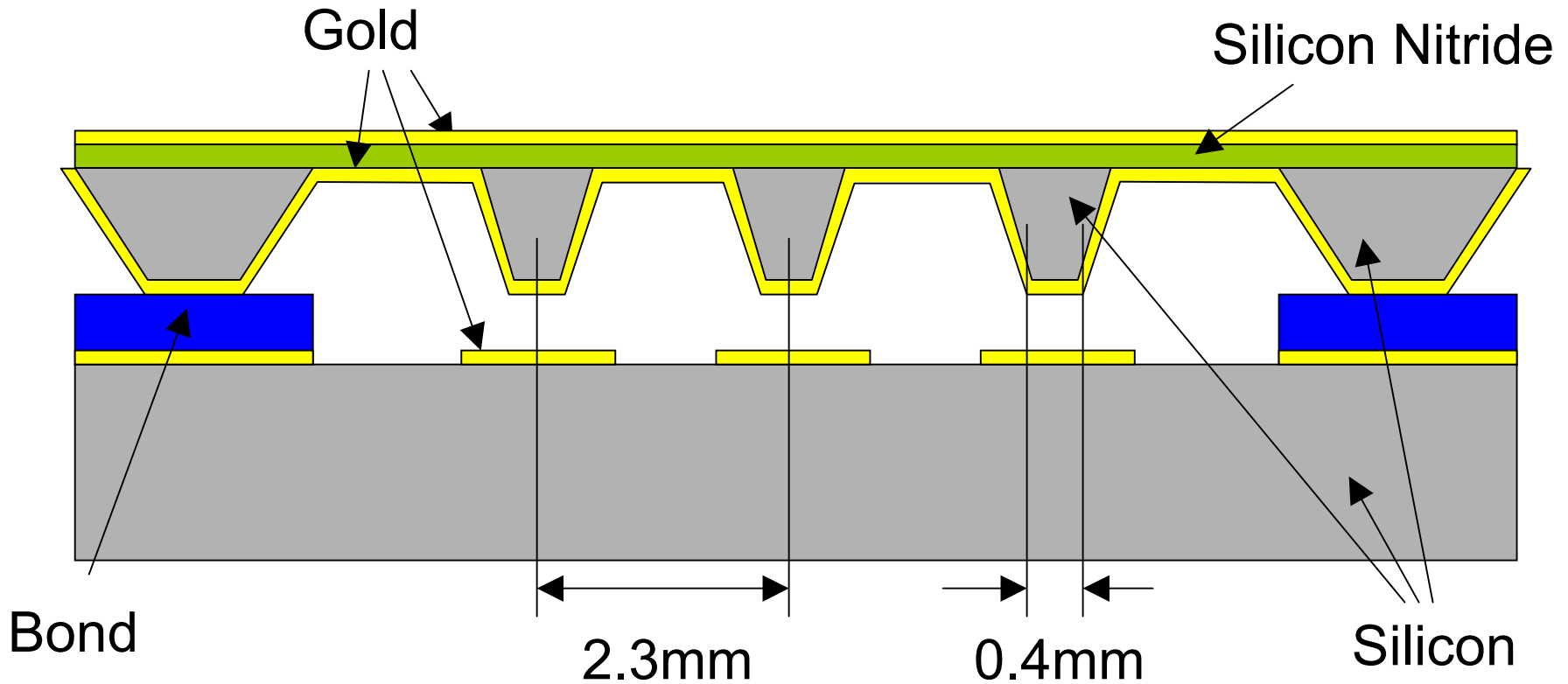


3D View of Mirror Architecture



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Cross-Section of Mirror Architecture



Stanford DM Photograph



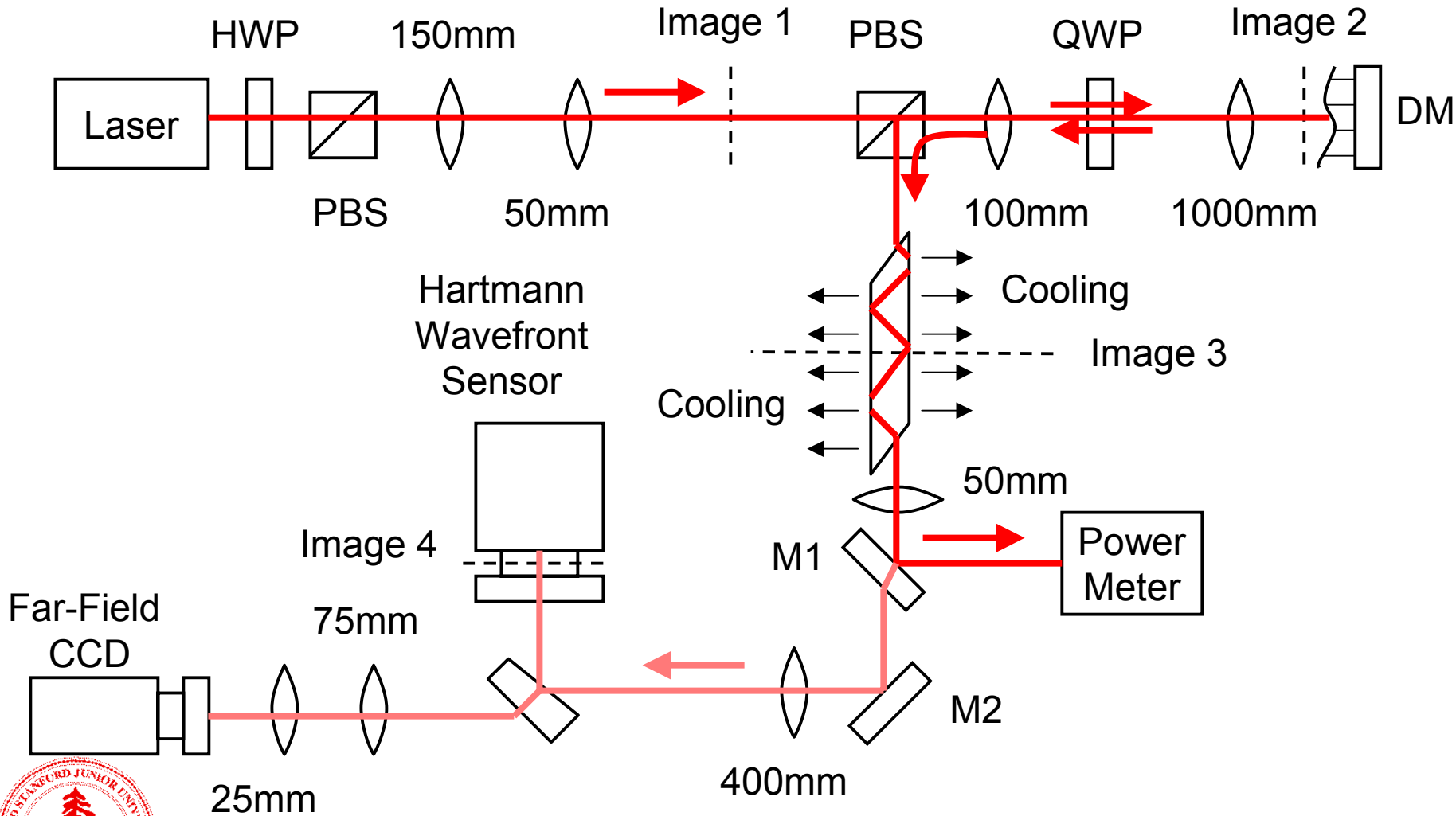
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Two-Layer DM Characteristics

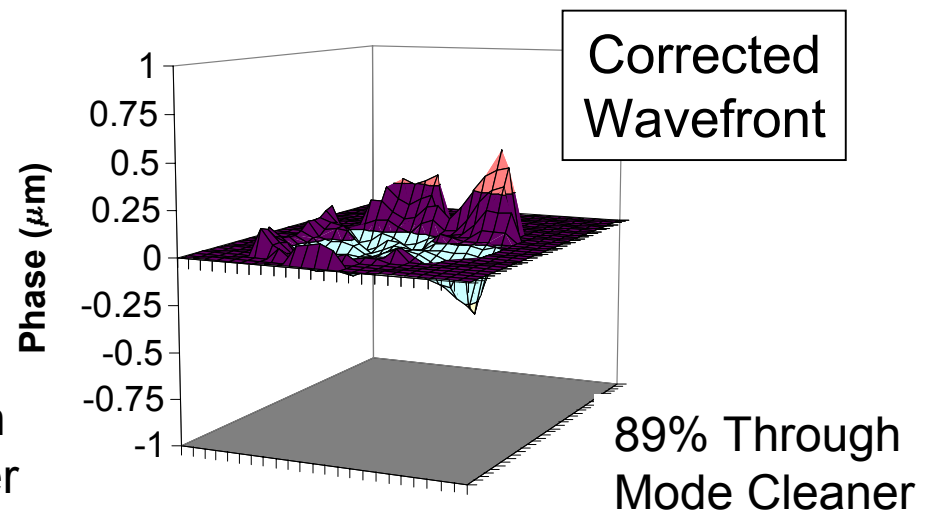
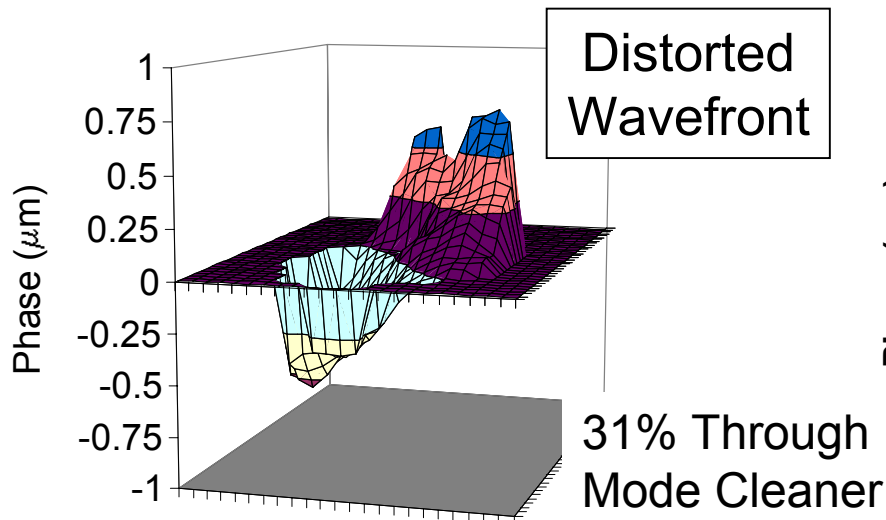
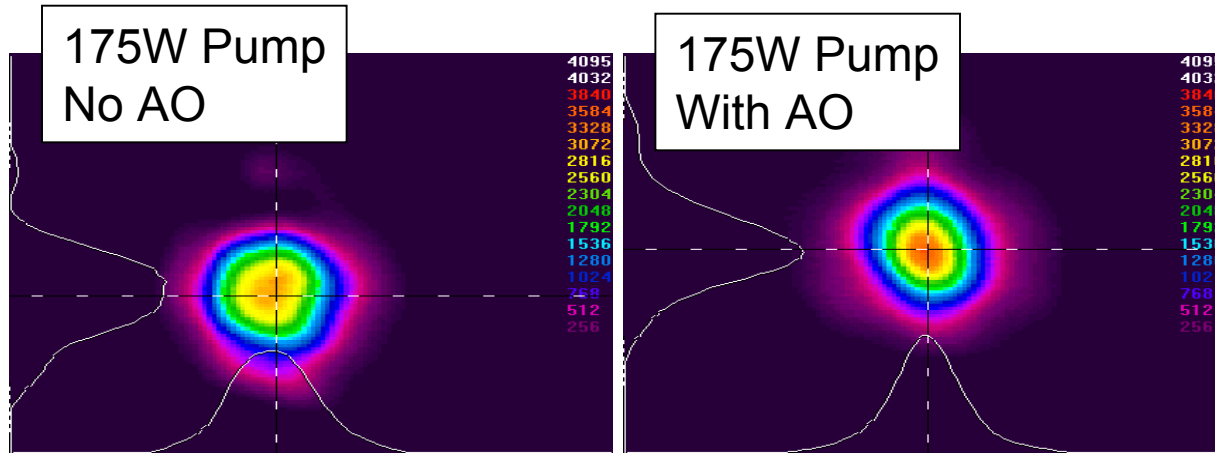
- 19 actuators with 2.3 mm spacing
- 1.6 cm aperture
- 10 μm throw in center actuator
- Low electrical power consumption
- 3.7 kHz mechanical resonance frequency
- Low-cost fabrication
 - Class 1000 clean room
 - Two-Mask Process



Thermal Distortion Compensation



Compensation Results

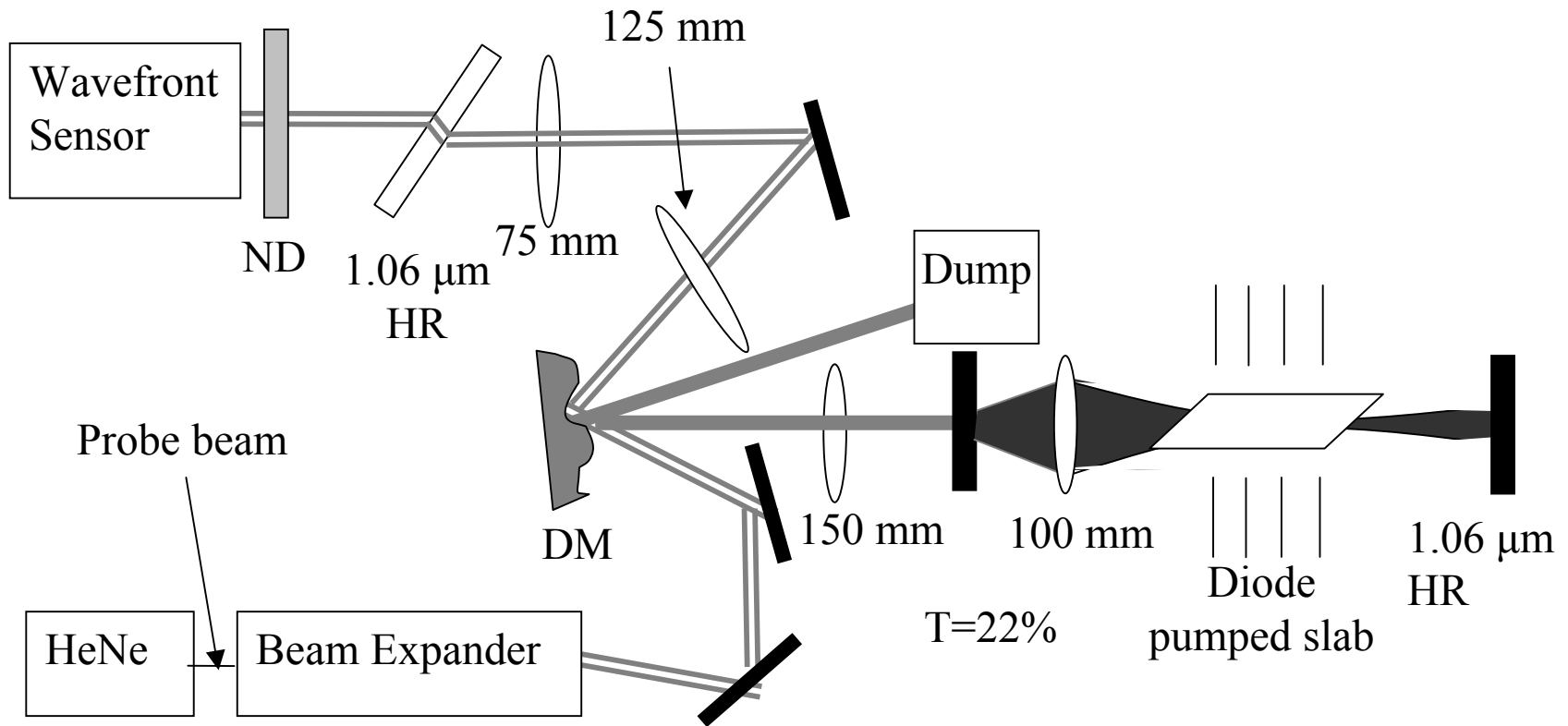


Two-Layer DM Advances

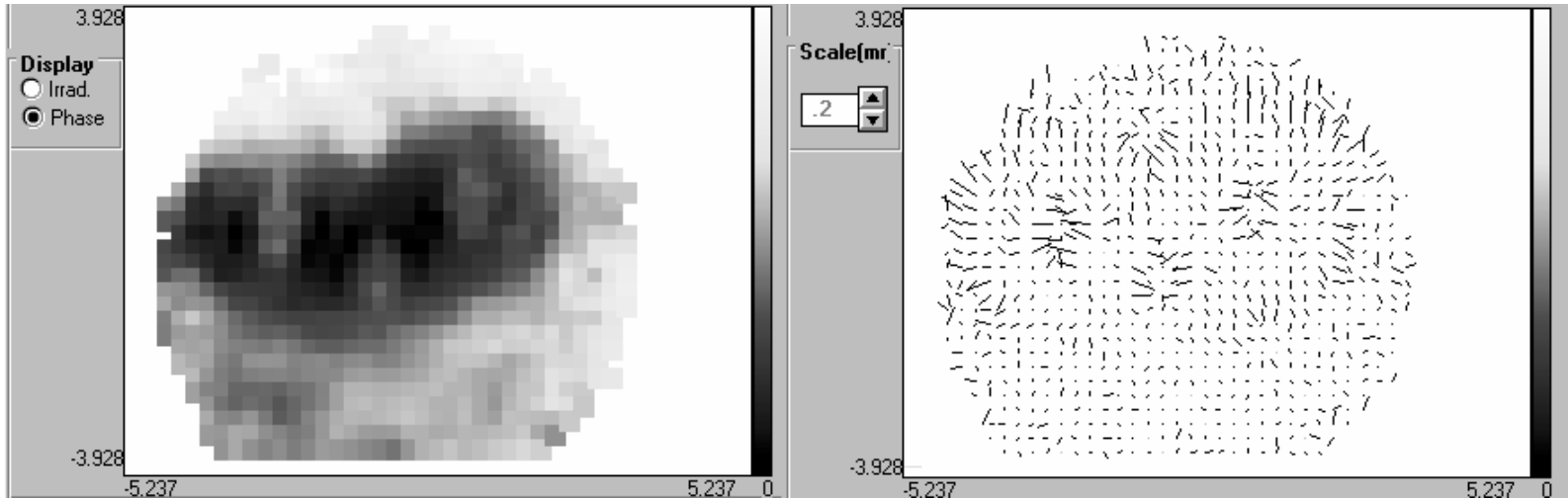
- **Possible to Preserve Mirror Surface**
 - All polishing and coating complete before processing
 - Mirror surface never exposed to etchant
- **Low Static Aberrations**
 - Bond annealing relaxed bonding stress
 - ~50 nm rms static aberration in an astigmatic term
- **Capable of bonding to silicon circuitry**
 - Can use CMOS to address for large actuator count
 - A polished silicon surface for electrode uniformity
 - No mismatch between layers
- **Robust**
 - Electrostatic snap-down does not cause damage.
 - Mirror is fully recovered by reducing voltage.



Power Handling Characterization



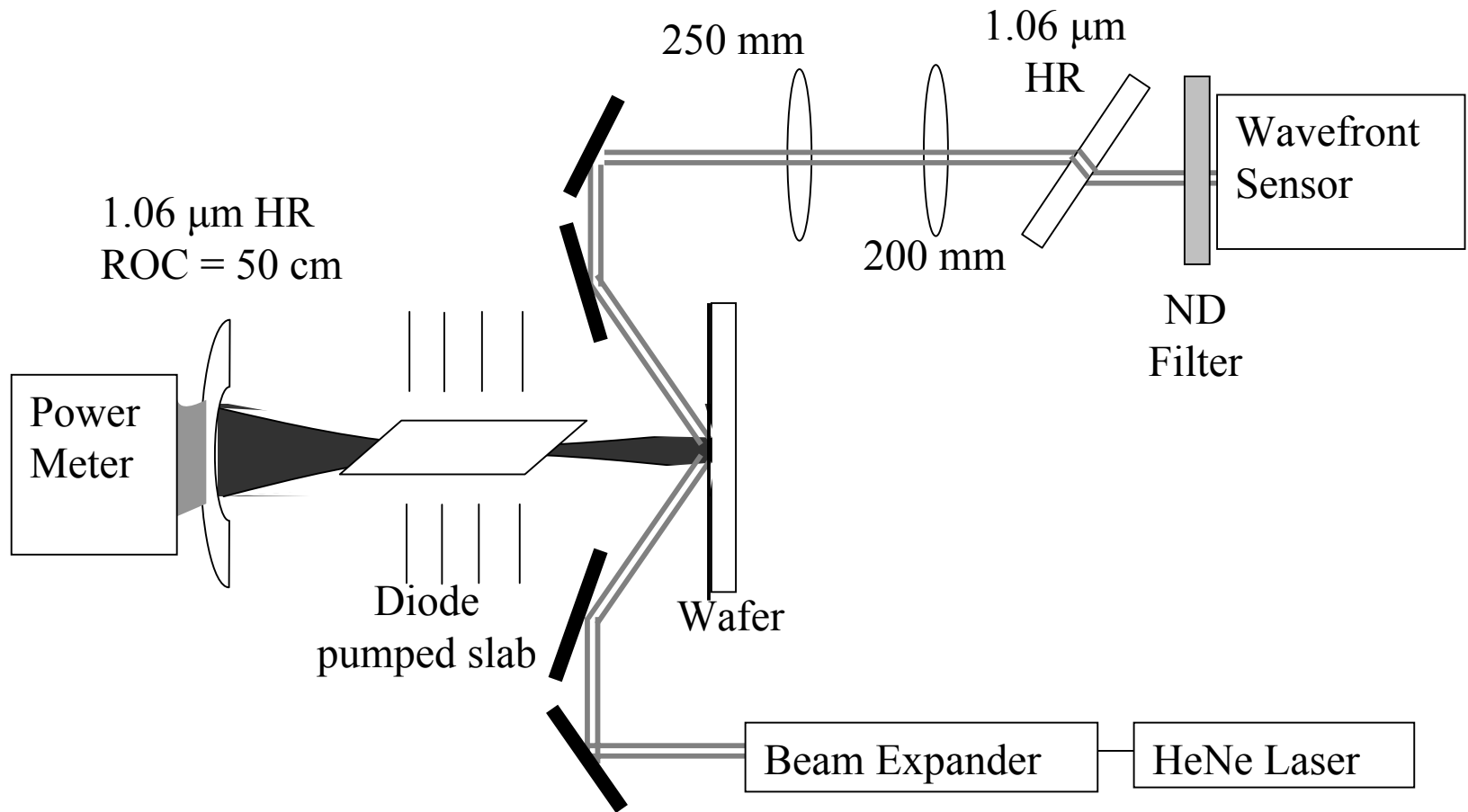
Gold-Coated DM Power Handling



Wavefront distortion when loaded with 41 W
of cw 1064 nm laser power (212 W/cm^2)
with 39.1 nm of rms distortion



HR Wafer Power Handling

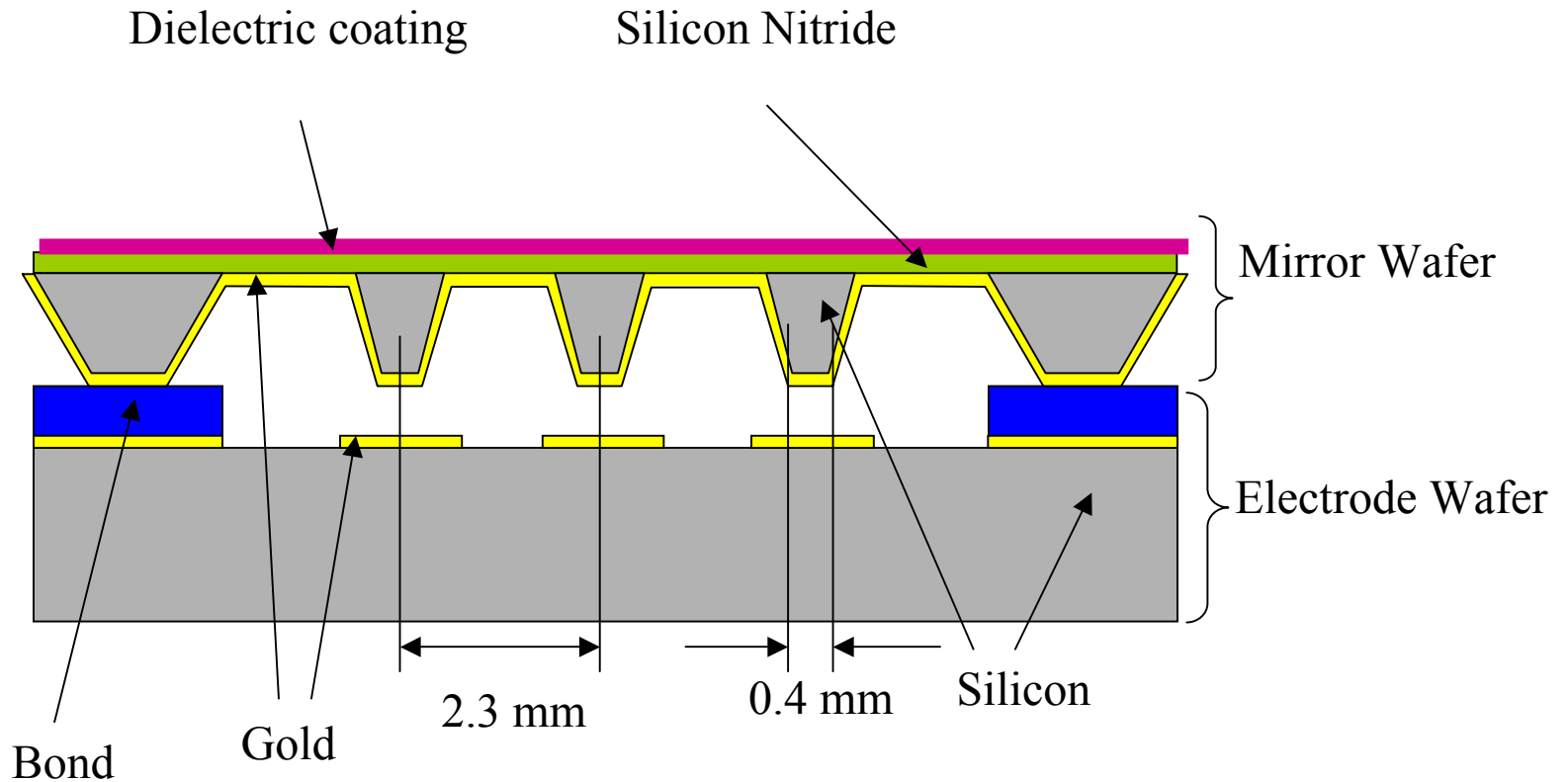


With 1.1 kW (39 kW/cm^2) of cw 1064 nm laser power, no thermally induced distortion was observed.

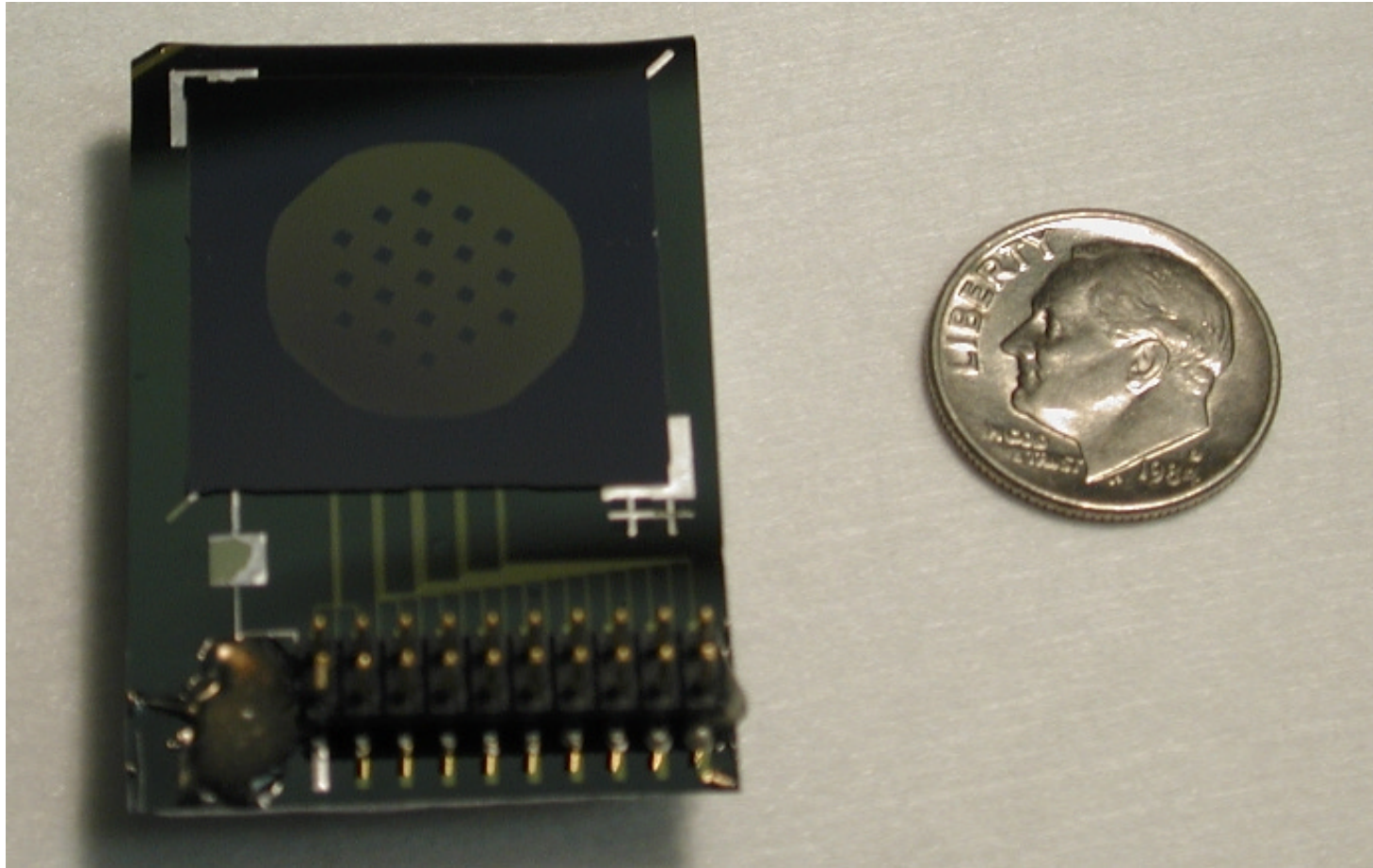
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High Reflectivity Deformable Mirror



High Reflectivity DM Photograph



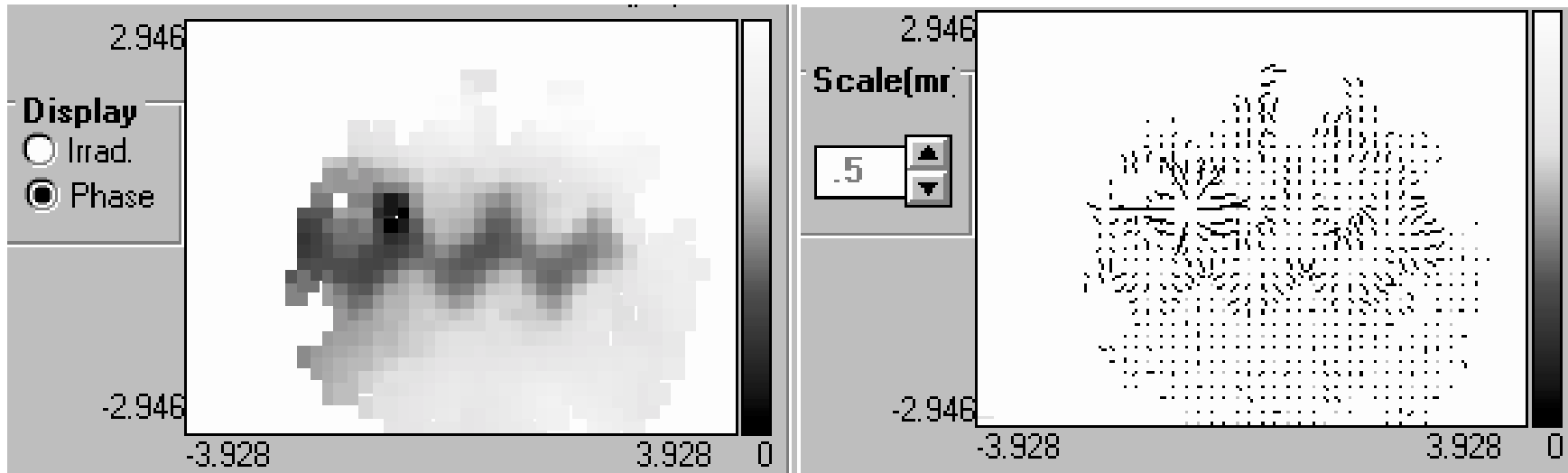
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Reliability Characterization

- Deformable mirror was cycled at 150V for 500 million cycles & no damage was observed
- 30 hours with 36 W of cw 1064 nm laser power with no damage
- Fully recoverable from electrostatic snap-down.



MLD-Coated DM Power Handling



Wavefront distortion when loaded with 41 W of cw 1064 nm laser power (212 W/cm^2) with 61.3 nm of rms distortion



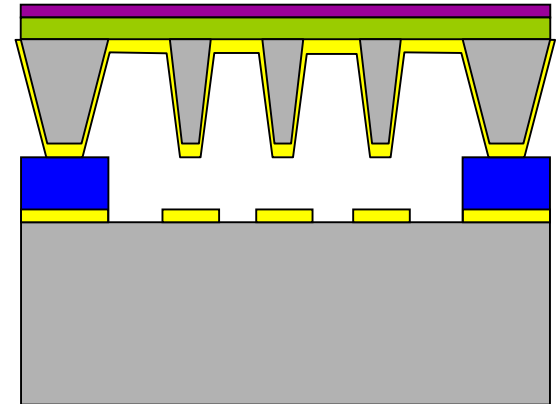
Thermally Induced Aberration Compensation

- Thermally loaded the MLD-coated DM with 22 W (350 W/cm²) of cw 1064 nm laser light
- Induced 88 nm rms distortion
- Used a dithering adaptive optics algorithm to reduce the distortion to 31 nm rms.

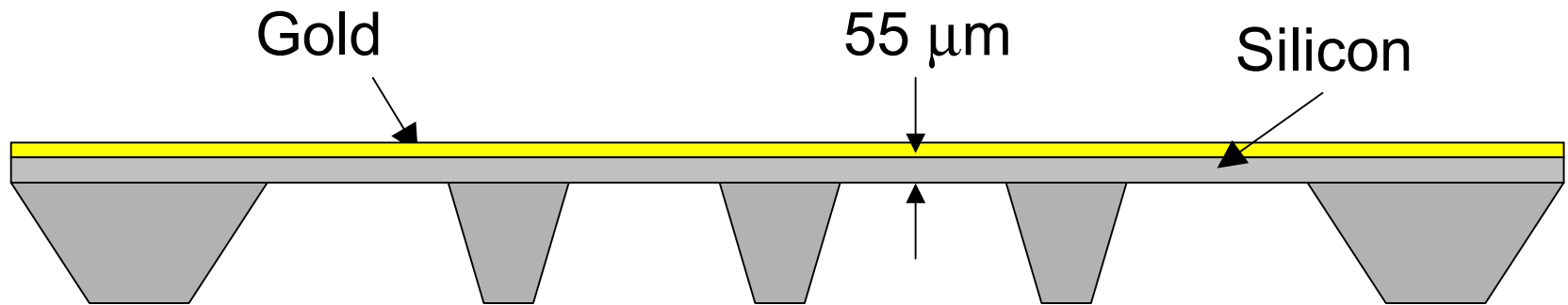


Thermal Loading Results

- Distortions concentrated on pillar edges
- Gold-coated DM had less thermally induced distortion
- Thermal Distortion Explanations
 - Differential thermal expansion between silicon pillars and silicon nitride
 - Non-uniform temperature distribution
 - Silicon pillars as effective “radiators”
 - Silicon pillars absorbed more light than gold



Gold-Coated All-Silicon DM Architecture

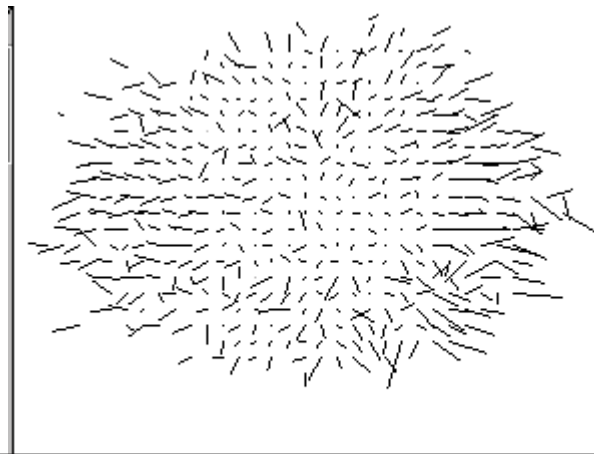
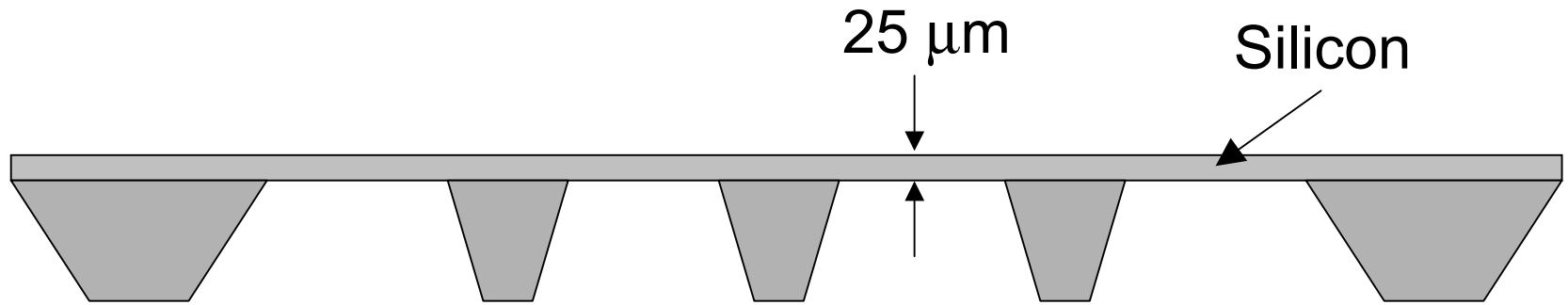


No wavefront distortion was observed even when loaded with 55 W of cw 1064 nm laser power ($300\text{W}/\text{cm}^2$).

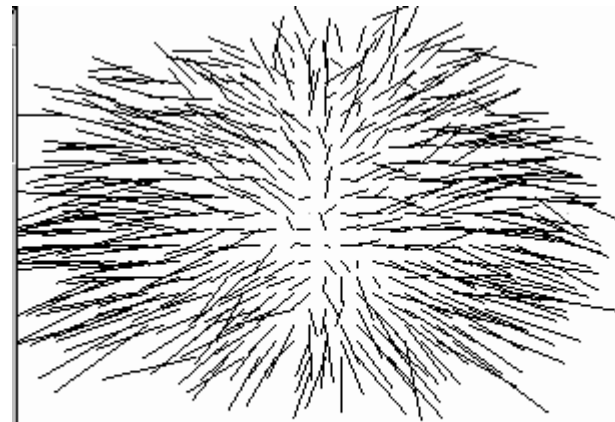
Non-tensile silicon had $\sim 10\lambda$ of sphere.



All-Silicon DM Architecture



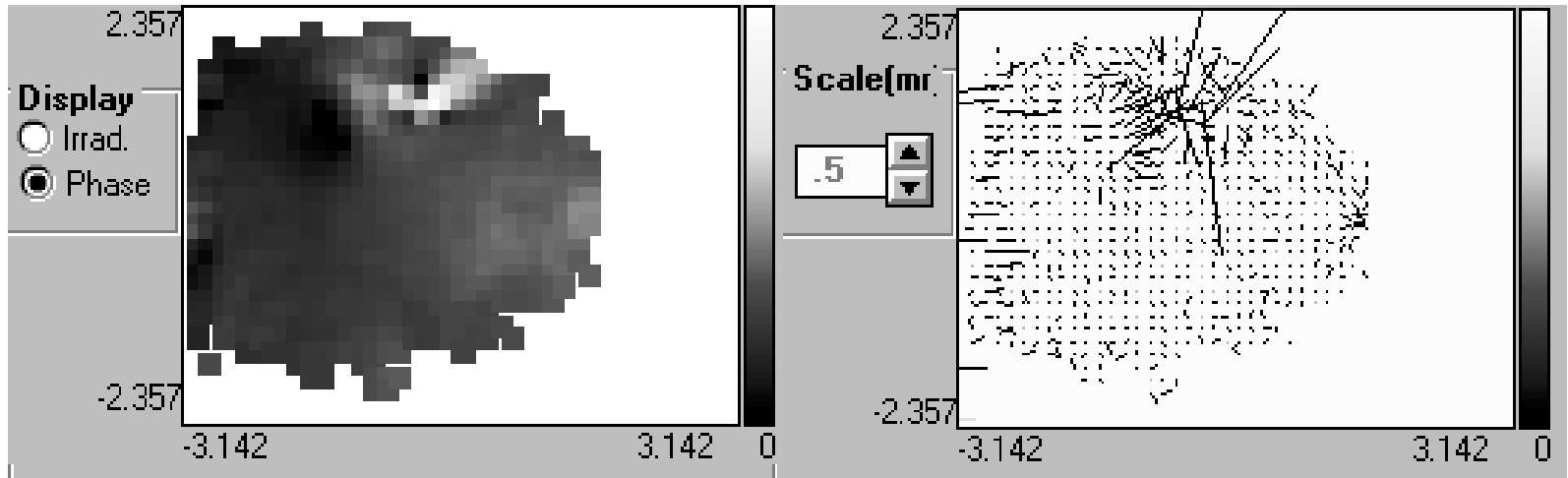
274 nm rms distortion with 1.3 W.



1123 nm rms distortion with 2.2 W.



Damage Threshold



- 25 kW/cm² (~600 W) appeared to increase temperature enough to permanently distort the mirror surface.
- Mechanism is probably thermal annealing.

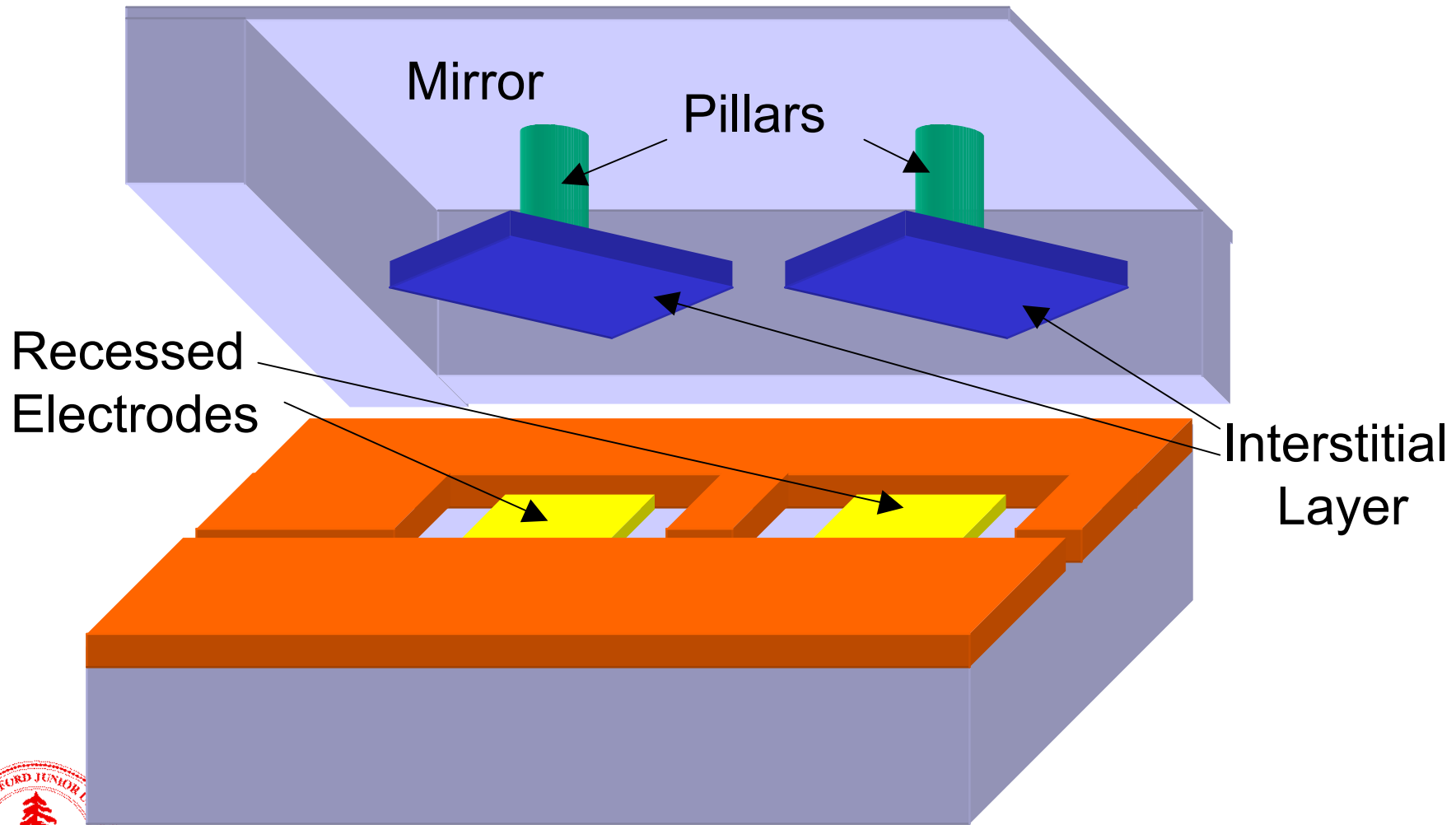


Future Work

- Conclusively determine cause of distortions.
- Fabrication of a single-crystal silicon MLD-coated deformable mirror with gold flash coating.
- Superior control algorithms
- Three-layer architecture



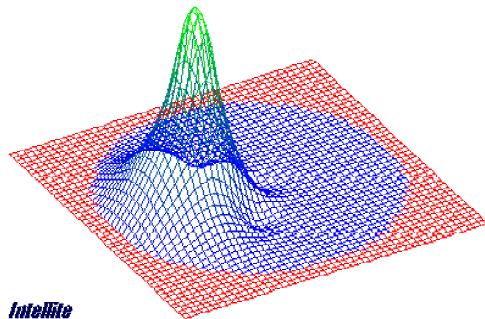
New Three-Layer Structure



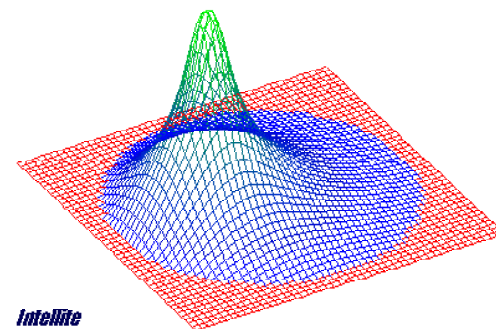
Advantages of Three Layer DM

- Less actuator crosstalk

PV(um):0.401



PV(um):3.752



- Resonance frequency that is fairly independent of mirror diameter



Conclusions

- We have demonstrated a robust, good surface quality DM that can compensate (to a large degree) for thermal distortions in transmissive optics
- We have presented an architecture that permits MLD stack to be deposited easily
- We have presented an architecture that can be easily integrated with silicon circuitry.
- We have demonstrated a closed loop system.



Acknowledgements

- Thanks to Marty Fejer, Patrick Lu, Todd Rutherford and Shally Saraf for assistance and advice.
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